



TRANSMITTAL FORM

(To be used for all correspondence after initial filing)

Application Number	10/695,479			
Filing Date	October 28, 2003			
First Named Inventor	Danilo Mascolo			
Art Unit	2818			
Examiner Name	David Nhu			
Attorney Docket No.	856063.754			

ENCLOSURES (about all that and the							
Fee Transmittal Form Fee Attached Amendment/Response After Final Affidavits/declaration(s) Extension of Time Request Express Abandonment Request Information Disclosure Statement; Form PTO-1449 Cited References Certified Copy of Priority Document(s) Response to Missing Parts under 37 C.F.R. 1.52 or 1.53 Response to Missing Parts/Incomplete Application		Drawing(s) Request for Corrected Filing Receipt Licensing-related Papers Petition Petition to Convert to a Provisional Application Power of Attorney, Revocation, Change of Correspondence Address Declaration Statement under 37 CFR 3.73(b) Terminal Disclaimer Request for Refund CD, Number of CD(s) Landscape Table on CI	After Allowance Communication to TC Appeal Communication to Board of Appeals and Interferences Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter Return Receipt Postcard Other Enclosure(s) (please identify below):				
Remarks							
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT							
Firm Name		ctual Property Law Group PLLC	Customer Number 38106				
Signature	Ha	~ 7					
Printed Name	Hai Han, Ph.	D.					
Date	March 31, 20	005 Reg.	No. 54,150				
CERTIFICATE OF TRANSMISSION/MAILING I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below. Signature							
Typed or printed n	ame Jaş	on Añover	Date: March 31, 2005				
This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to							

process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

PATENT

Thereby certify that on the date specified below, this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

March 31, 2005

Jason Añover

Date

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants

Danilo Mascolo et al.

Application No.

10/695,479

Filed

October 28, 2003

For

SINGLE ELECTRON TRANSISTOR MANUFACTURING

METHOD BY ELECTRO-MIGRATION OF METALLIC

NANOCLUSTERS

Examiner

David Nhu

Art Unit

2818

Docket No.

: 856063.754

Date

March 31, 2005

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents:

In accordance with 37 CFR 1.56 and 1.97 through 1.98, applicants wish to make known to the U.S. Patent and Trademark Office the references set forth on the attached Form PTO-1449. Copies of the cited U.S. patents and published patent applications are not required and accordingly have not been provided. Copies of all other cited references are enclosed. As to any reference cited, applicants do not admit that it is "prior art" under 35 U.S.C. §§ 102 or 103, and specifically reserve the right to traverse or antedate any such reference, as by a showing under 37 CFR 1.131 or other method. Although the aforesaid references are made known to the

Patent and Trademark Office in compliance with applicants' duty to disclose all information they are aware of which is believed relevant to the examination of the above-identified application, applicants believe that their invention is patentable.

We hereby certify that each of the references set forth on the attached form PTO-1449 was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

Please acknowledge receipt of this Information Disclosure Statement and kindly make the cited references of record in the above-identified application.

Applicants believe this Information Disclosure Statement has been timely filed, however, the Director is authorized to charge any fee due by way of this Information Disclosure Statement to our Deposit Account No. 19-1090.

Respectfully submitted,
Seed Intellectual Property Law Group PLLC

Hai Han, Ph.D.

Registration No. 54,150

Enclosures:

Postcard Form PTO-1449 Cited References (2)

701 Fifth Avenue, Suite 6300 Seattle, Washington 98104-7092

Phone: (206) 622-4900 Fax: (206) 682-6031

576721

Date: 03/31/005

FORM PTO-1449 (REV.7.80) P E		DATE	ENIT AN	ID TO A DEX	COMMERCE IARK OFFICE	ATTY. DOCKET NO. APPLICATION NO.				
OLLE	\c)		2111 74	TO THORDEN	Budt Office	856063.754 10/695,479 APPLICANTS				
1	DIFOR	MATION DISCLOSURE	STATE	MENT		Danilo Mascolo et al.				
APR O & 20	PATENT AND TRADEMARK OFFICE PATENT AND TRADE					FILING DATE	GROUP ART UNIT			
Zat								2818		
*EVAMINED										
INITIAL	+	OCUMENT NUMBER	DATE		NAME		CLA		IF APPRO	
A.	A 5,	,997,958	12/07/99		Sato et al.		427	468		
AI	в 6,	,057,556	05/02/00		Gubin et al.		257	39		
AC	c 6,	,313,479	11/06/01		Zhang et al.		257	14	-	,
AI	p 20	003/0102444	06/	05/03	Deppert et al.		250	492.22		
Al	E 20	003/0048619	03/	13/03	Kaler et a	1	361	760		
AI	F		•							
AC	3									
Ai	Н									
AI				·		,				
AJ										
FOREIGN PATENT DOCUMENTS										
		DOCUMENT NUMBE	R	DATE	:	COUNTRY		TRANSI	ATION NO	
Al	ζ \	WO 03/016209	A1 02/27/0		03 WIP	WIPO				
AL										
AN	и									·
AN	7									
AC				·						
		ОТНЕ	R PI	RIOR A	RT (Including	Author, Title, Date, Pertinent Pa	iges, Etc.,)		
AF	,	i				t Formation Using Ret	_	•	Ion	
	-	Deposition,"	Appl	lied Phy	sics Letter	s 73(22):3223-3225, N	ovem	ber 30, 1998.		
AC	2								·	
AR	<u> </u>						 	· · · · · · · · · · · · · · · · · · ·		
EXAMINER						DATE CONSIDERED			,	
* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).										